

# Nanosecond Laser Damage Resistance of Differently Prepared Semi-finished Parts of Optical Multimode Fibers

G. Mann<sup>1</sup>, J. Vogel<sup>1</sup>, R. Preuss<sup>1</sup>  
P. Vaziri<sup>1</sup>, M. Zoheidi<sup>2</sup>, M. Eberstein<sup>1</sup>, J. Krüger<sup>1</sup>

<sup>1</sup> Federal Institute for Materials Research and Testing, Unter den Eichen 87, D-12205 Berlin, Germany

<sup>2</sup> FiberTech GmbH, Nalepastrasse 171, D-12459 Berlin, Germany

## Introduction

- Optical multimode fibers are applied in fields like automotive, defense, aviation, medicine and biotechnology
- High power applications (fiber lasers, laser light cable) are of increasing interest
- Besides geometrical parameters and absorption behavior of fibers the laser damage threshold is a major aspect

## Problem

Laser-induced damage threshold (LIDT) can limit the performance of complex optical systems with respect to beam quality and transmissible power

Question:

Does the pulling process (pulling temperature, cooling rate, mechanical stress) and the polishing of fiber end faces influence the LIDT?

## Experimental

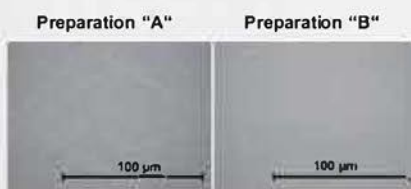
Specimens:

- Material: SiO<sub>2</sub> glass (F300, Heraeus)
- Multimode fiber preform
- Cylindrical samples: 20 mm diameter and 10 mm thick
- Transformation temperature (F300): 1070 °C

Surface preparation:

According to sequences "A" and "B"

Surface Preparation Steps	"A"	"B"
Grinding with abrasive grains with grain diameters down to ≈15 μm	*	*
Polishing with Ce <sub>2</sub> O <sub>3</sub> suspension with Ce <sub>2</sub> O <sub>3</sub> grain diameters of 3 μm		*
Polishing with diamond suspension with diamond grain diameters of 3 μm	*	*
Polishing with diamond suspension with diamond grain diameters of 1 μm	*	*
Polishing with diamond suspension with diamond grain diameters of 0.25 μm	*	*



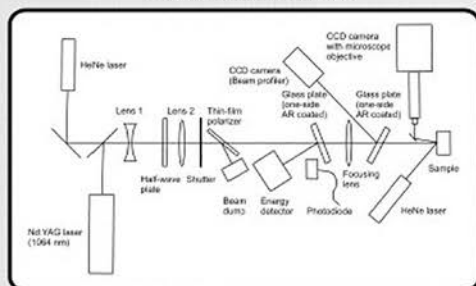
Thermal treatment:

- Tempered at 1100 °C, 1300 °C and 1500 °C for 15 min.
- Cooling rates: 10 K/min (oven) and 10<sup>5</sup> K/min (quenched in air)

Laser setup:

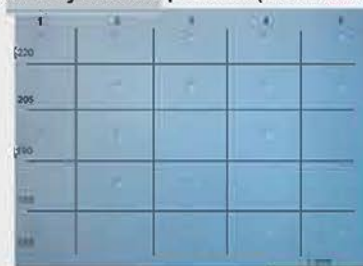
- Nd:YAG laser
- 1064 nm, 12 mJ, 10 Hz
- Gaussian beam profile
- 2w = 50 ± 2 μm
- M<sup>2</sup> = 1.6
- Precision of absolute LIDT value: 25%
- Maximum laser fluence:  $F_0 = \frac{2E_0}{\pi W^2}$  (pulse energy)

Experimental setup:



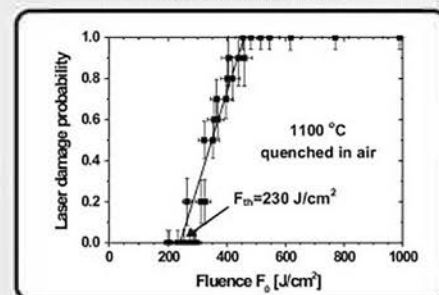
According to standard ISO 11254-1/2:  
Part 1: 1-on-1 Test / Part 2: S-on-1 Test

Array of laser induced damage sites on a cylindrical preform (1-on-1 test):



top: consecutive numbers of damage sites  
left: relative laser power

Interpretation of data:



Damage probability vs. maximum laser fluence

## Results

Maximum temperature [°C]	Surface preparation	F <sub>th</sub> cooling rate 10 K/min <sup>-1</sup> [J/cm <sup>2</sup> ]	F <sub>th</sub> cooling rate 10 <sup>5</sup> K/min <sup>-1</sup> [J/cm <sup>2</sup> ]
20	B	320	-
1100	B	210	230
1300	B	250	350
1500	B	320	250
1500	A	130	-

Damage threshold fluences F<sub>th</sub> for cylindrical preforms with different thermal history and varying surface preparation (1-on-1)

Maximum temperature [°C]	Surface preparation	F <sub>th</sub> 1-on-1 [J/cm <sup>2</sup> ]	F <sub>th</sub> 100-on-1 [J/cm <sup>2</sup> ]
20	B	320	320
1100	B	230	210
1300	B	350	270
1500	B	250	230

Damage threshold fluences F<sub>th</sub> for cylindrical preforms with different thermal history  
Comparison between (1-on-1) and (100-on-1) laser treatment

## Conclusions

- LIDT values between 150 J/cm<sup>2</sup> and 350 J/cm<sup>2</sup> (1064 nm, 15 ns, unseeded)
- An insufficient polishing procedure decreases the damage resistance significantly
- A thermal pre-treatment enhances the damage threshold
- A multi pulse impact results in lower thresholds compared to the single pulse illumination (incubation effect)



## Funding

Financial support by the federal state Berlin in the framework of the ProFIT program partly financed by the European Union (EFRE) is gratefully acknowledged.

